

NGC-212/12-1167

**IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE**

**Patent Application**

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FEB 02 2006

**Inventor(s):** Raffi Nazare Elmadjian

**Case No.:** NGC-212/12-1167

**Serial No.:** 10/688,238

**Filing Date:** 10/18/2003

**Title:** WAFER ETCHING TECHNIQUES

**Examiner**

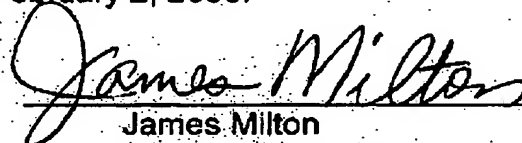
**Art Unit:**

**Ken Chan Chin**

**1765**

**CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being sent via facsimile transmission to Commissioner for Patents, Mail Stop Amendment, Group Art Unit 1765, Attention: Examiner Ken Chan Chin, P.O. Box 1450, Alexandria, VA 22313-1450, at fax number (571) 273-8300, on February 2, 2006.



James Milton  
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Date of Signature: February 2, 2006

Commissioner for Patents  
Mail Stop Amendment  
Group Art Unit 1765  
**Attention: Examiner Ken Chan Chin**  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Fax Number (571) 273-8300

**AMENDMENT AFTER FINAL OFFICE ACTION**

Dear Sir:

This response is being filed in reference to the Final Office Action dated November 10, 2005 in connection with the above-designated application. A response to the Office Action is due February 10, 2006. Therefore, this Response is timely filed.